HDP/SB/21 based on PTO/SB/21 (08-00)

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TRANSMITTA	L
FORM	

(to be used for all correspondence after initial filing)

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Appropriemation	10/632,825
Filing Date	August 4, 2003
Inventor(s)	Yun-Jung LEE et al.
Group Art Unit	2826
Examiner Name	Evan T. Pert
Attorney Docket Number	0962 000016/US

	At	torne	ey Docket Number	9862-	000016/US		
	ENCLOSURES (check all that apply)						
Fee Transmittal F	- Form		Assignment Papers (for an Application)		After Allowance Communication to Group		
Fee Attached	l		Letter to the Official Draftsperson and Sheets of Formal Drawing(s)		LETTER SUBMITTING APPEAL BRIEF AND APPEAL BRIEF (w/clear version of pending claims)		
Amendment		Licensing-r	elate	d Papers	Appeal Communication to Group (Notice of Appeal, Brief, Reply Brief)		
After Final		Petition			☐ Pro	oprietary Information	
Affidavits/dec	laration(s)	Petition to 0 Provisional			Status Letter		
Extension of Time	e Request			ey, Revocation espondence Address	Other Enclosure(s) (please identify below):		
Express Abandonment Request		☐ Terminal Disclaimer ☐ Request for Refund		Re-Submission of Previously Filed Information Disclosure Statement, with attachments			
☐ Information Disclo	osure Statement w/ (1)	CD, Numbe	CD, Number of CD(s)				
Certified Copy of Document(s)	Priority	Remarks					
Response to Miss Incomplete Applic							
Response to Missing Parts under 37 CFR 1.52 or 1.53							
	SIGNA	TURE OF APP	LICA	ANT, ATTORNEY, OF	RAGEN	NT	
Firm <i>or</i> Individual name	Harness, Dicker &	Pierce, P.L.C.	Atternay Name			Reg. No. 35,094	
Signature	A I						
Date	February 6, 200)6					
	11						



PATENT 9862-000016/US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Yun-Jung LEE et al.

CONF. NO.: 9195

SERIAL NO.:

10/632,825

GROUP: 2826

FILED:

August 4, 2003

EXAMINER: Evan T. Pert

FOR:

METHOD OF FORMING OXIDE LAYER USING ATOMIC

LAYER DEPOSITION METHOD AND METHOD OF

FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

USING THE SAME

RE-SUBMISSION OF PREVIOUSLY FILED INFORMATION DISCLOSURE STATEMENT

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 Mail Stop Amendment

February 6, 2006

Dear Sir:

In the Office Action dated October 17, 2005, the Examiner stated that the Information Disclosure Statement filed August 3, 2005 (a copy of which is attached herewith), did not comply with 37 C.F.R. 1.98(a)(3) because no translation of the Korean Office Action was provided. Thus, the Examiner did not consider any documents cited on the form PTO-1449.

The Examiner is not required to nor do Applicants request the Examiner's consideration of the Korean Office Action. The Korean Office Action is merely provided as proof of the date on which the Office Action was issued such that Applicants can provide proper certification under 37 C.F.R. § 1.97(e). Regardless, however, it appears that the Examiner has

overlooked, and still failed to consider, the additional reference U.S. Patent

No. 6,391,803 listed on the form PTO-1449. Accordingly, Applicants request
that **the Examiner consider U.S. Patent No. 6,390,803**, and indicate such
in a PTO correspondence. Because Applicants originally filed this
Information Disclosure Statement in a timely manner, no further fees
and/or certification are necessary.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

HARNESS, DICKEY & PIERCE, PLC

 By_{-}

John A. Gastellano Reg. No. 35,094

JAC/AMW:jcp

P.O. Bok 8910 Reston, VA 20195 (703) 668-8000

9862-000016/US	e: August 4, 2003	OXIDE LAYER USING ATOMIC ETHOD AND METHOD OF FORMING CAPACITOR		W 2 10	AUG 0 3 2005 LG	AND EMBEROSE	USPTO Date Stamp	Filed: 08/03/2005
Case No.:	Filing Date:	YER USING AT D METHOD OF					ce, P.L.C.	JAC/AMW:lak
LEE et al.	2	METHOD OF FORMING OXIDE LAYER USING ATOMIC LAYER DEPOSITION METHOD AND METHOD OF FORN	eceipt of:	re Statement			o Harness, Dickey & Pierce, P.L.C.	Attorney: JAC
t: Yun-Jung LEE et al	.: 10/632,825	METHOD OF FORMING LAYER DEPOSITION M	Please acknowledge receipt of	Information Disclosure Stater PTO Form 1449	References (1) Korean Office Action		By stamping and returning to Harness,	08/11/2005
Applicant:	Serial No.:	Title: N	Please a	Informa PTO Fo	References (1) Korean Office		By stampin	Due: (





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/632,825

Filing Date:

August 4, 2003

Applicant:

Yun-Jung LEE et al.

Group Art Unit:

2812

Examiner:

Evan T. Pert

Title:

Method of Forming Oxide Layer Using Atomic Layer

Deposition Method and Method of Forming Capacitor

of Semiconductor Device Using the Same

Attorney Docket:

9862-000016/US

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 Mail Stop Amendment August 3, 2005

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant hereby submits an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS, AND OTHER INFORMATION

The patents, publications and other information submitted for consideration by the Office (except unpublished U.S. patent applications) are listed on Form PTO-1449 attached hereto.

II. COPIES

A. Submitted herewith is a legible copy of (i) each foreign patent; (ii) each publication or that portion which caused it to be listed, other than U.S. patents and U.S. patent application publications unless required by the Office; (iii) for each cited pending unpublished U.S. application listed below in Section IV, the application specification including the claims, and any drawing of the application, or that portion of the application which caused it to be listed including any claims directed to that portion; and (iv) all other information or that portion which caused it to be listed.

	B. Any patents, publications or other in PTO-1449 or on the copies of Form PTO-892 were previously cited by or submitted to the P which has been relied upon for an earlier filing	2, but which are not enclosed herewith, TO in one of the following applications
	U.S. Serial Number	U.S. Filing Date
	C. Because the present application was/is be of the U.S. patents or U.S. patent application attached Form PTO-1449 are enclosed put \$ 1.98(a)(2)(i). Any foreign patent document attached Form PTO-1449 are enclosed herewith	n publications which are listed on the arsuant to the waiver of 37 C.F.R. ts or non-patent literature listed on the
	D. This is a PCT application in the entry of A copy of the International Search Report is a The documents listed on the International Search PTO-1449 for consideration by the Examiner from this application. Since the International SIPO search authorities, copies of these refere USPTO under the trilateral agreement and above-identified application. (MPEP 1893.03)	ttached for the Examiner's information. It is the Report are listed on the attached Form and for listing on any patent resulting search Report was from the US, EPO, or inces should have been supplied to the are believed to be in the file of the
III.	CONCISE EXPLANATION OF THE RELEV	ANCE (check at least one box)
	A. Except as may be indicated below in (B) information are in the English language (conci-	
	B. A concise explanation of the relevance information listed that is not in the English § 1.98(a)(3)):	e of each patent, publication or other language is as follows (see 37 C.F.R.
	 See the attached foreign patent of foreign application: Korean Of English translations are provided Other: 	
	C. The following additional informati consideration.	on is provided for the Examiner's
IV.	CROSS REFERENCE TO RELATED APPLIC	CATION(S)
	A. The Examiner is advised that the follows subject matter that may be related to the prese application(s) to the Examiner's attention, confidentiality provisions of 35 U.S.C. § 122.	ent application. By bringing this(these)

Serial No.

Filing Date

Art Unit

V.	THIS IDS IS BEING FILED UNDER
	A. 37 C.F.R. § 1.97(b): (check only one box)
	1. within three months of the filing date of a national application other than a continued prosecution application under 37 C.F.R. § 1.53(d) (37 C.F.R. § 1.97(b)(1)). No fee or certification is required.
	2. within three months of the date of entry of the national stage as set forth in 37 C.F.R. §1.491 in an international application (37 C.F.R. § 1.97(b)(2)). No fee or certification is required.
	3. before the mailing of a first Office Action on the merits (37 C.F.R. § 1.97(b)(3)). No fee or certification is required. In the event that a first Office Action on the merits has been issued, please consider this IDS under 37 C.F.R. § 1.97(c) and see the certification under 37 C.F.R. § 1.97(e) below; or, if no certification has been made, charge our deposit account a fee in the amount of \$180.00 as required by 37 C.F.R. § 1.17(p).
	4. before the mailing of a first Office Action after the filing of a request for continued examination under 37 C.F.R. § 1.114. No fee or certification is required.
	B. 37 C.F.R. § 1.97(c): (check <u>only</u> one box)
	before the mailing date of either any Final Office Action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution.
	1. No certification; therefore, a fee in the amount of \$180.00 is required by 37 C.F.R. § 1.17(p).
	2. See the certification below. No fee is required.
	C. 37 C.F.R. § 1.97(d):
	after the mailing date of either a Final Office Action under 37 C.F.R. § 1.113 or a Notice of Allowance under 37 C.F.R. § 1.311, yet on or before payment of the issue fee.

VI.	CERTIFICATION UNDER 37 C.F.R. § 1.97(e): (check only one box)
	The undersigned hereby certifies that:
	A. \(\subseteq \) each item of information contained in this IDS was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS (See 37 C.F.R. \§ 1.97(e)(1)). See further statement under 37 C.F.R. \§ 1.704(d) below in section VII, if applicable; or
	B. no item of information contained in this IDS was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making reasonable inquiry, no item of information contained in this IDS was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this IDS (See 37 C.F.R. § 1.97(e)(2)).
	C. Some of the items of information were first cited in a communication from a foreign patent office. As to this information, the undersigned hereby certifies that each item of information contained in this IDS was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS. As to the remaining information, the undersigned hereby certifies that no item of this remaining information contained in this IDS was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making reasonable inquiry, no item of information contained in this IDS was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this IDS.
VII.	STATEMENT UNDER 37 C.F.R. § 1.704(d)
	The undersigned hereby states that:
foreign any inc IDS.	each item of information contained in this IDS was cited in a communication from a patent office in a counterpart application and this communication was not received by dividual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of this
VIII.	PAYMENT OF FEES (check only one box)
	A. No fee is believed to be due in light of the above-provided certification.
	B. A check in the amount of \$180.00 is enclosed for the above-identified fee.

1. See the certification below. A fee in the amount of \$180.00 is required by 37 C.F.R. § 1.17(p).

U.S. Application No. Attorney Docket No. Page 5 of 5

C. Please charge Deposit Account No. 08-0750 in the amount of \$180.00 for the above-indicated fee. A duplicate copy of this paper is attached.

The above references are being cited only in the interest of candor and without any admission that they constitute statutory prior art, contain matter which anticipates the invention, or which would render the same obvious, either singly or in combination, to a person of ordinary skill in the art. Furthermore, this Information Disclosure Statement shall not be construed as a representation that a search has been made.

If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 08-0750.

Please charge any additional fees or credit any overpayment pursuant to 37 C.F.R. §§ 1.16 or 1.17 to Deposit Account No. 08-0750.

Respectfully submitted,

HARNESS, DICKEY, & PIERCE, P.L.C.

Rv

John A. Castellano, Reg. No. 35,094

P.O. Bok 8910

Reston, Virginia 20195

(703) 668-8000

JAC/AMW:lak

Enclosures:	\boxtimes	Form PTO-1449(s) (1 sheet(s))
		Documents
	\boxtimes	Korean Office Action
		Fee
		Other:

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	FORM H	FORM HDP-1449 (Based on Form PTO-1449)			9862-000016/US 10/632,825						
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U.S. PA	TENT DOCUM	MENTS	MATA	OFFIG ?							
Ref. Desig.	Examiner's Initials	Document Number	Date	Name		Class/ Subclas	ss	(If appropri	ate)		
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OTHER	OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)										
Ref. Desig.	Examiner's Initials										
		Korean Office Action dated May 11, 2005									
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Examiner:	Date Considered: